

Notice of References Cited	Application/Control No. 10/780,589	Applicant(s)/Patent Under Reexamination LIN et al.	
	Examiner Lee, Calvin	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-2003/0194847	10-2003	Chen et al.	438/407
	D	US-2005/0074930	04-2005	Chen et al.	438/151
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NON-PATENT DOCUMENTS

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